

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Nobuo Kimura et al.

Application No.: 10/553,109

Confirmation No.: 2398

Filed: March 13, 2006

Art Unit: 1762

For: METHOD FOR PRODUCING ORGANIC THIN  
FILM

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Examiner: William P. Fletcher III

**RESPONSE TO RESTRICTION REQUIREMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In the Office Action mailed August 8, 2007, the Examiner has required restriction of the claims to one of the following:

Group I, claims 1-4, 12, 14, 19, 22-29, and 55-67, drawn to a method for producing an organic thin film;

Group II, claims 35-37, 41, and 42, drawn to a self-assembly film; and

Group III, claim 44, drawn to a chemically absorbed film.

Applicants hereby elect Group I, claims 1-4, 12, 14, 19, 22-29, 49 and 55-67 for continued examination, without traverse.

Applicants believe the application is in condition for allowance. If there are any remaining issues that the Examiner believes could be resolved through either a Supplemental